

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

INFORMATION DISCLOSURE STATEMENT

In re Patent Application of:)	
)	Group Art Unit: 2113
Yoshito Katano)	
)	Examiner: Yolanda L. Wilson
Application No. 10/597,353)	
Filed: January 27, 2005)	
For: SEMICONDUCTOR DEVICE AND)	
PROCESSING METHOD FOR STARTING)	
THE SAME)	

Commissioner For Patents
P.O. Box 1450
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S I R:

In accordance with the provisions of 37 C.F.R. § 1.56, Applicants request that citation and examination of the references identified on the attached PTO-SB08A form, in accordance with 37 C.F.R. §1.98, be made during the course of examination of the above-referenced application for United States Letters Patent. These references were cited in an EP Communication issued on June 6, 2008, in connection with EP Application No. 200604823-5. Copies of the foreign references and English abstracts are attached as is a copy of the EP Communication.

Respectfully submitted,

/David R. Metzger/ (Reg. No. 32,919)

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